Docket No.: 50006-135



TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tomohiro HOSOKAWA, et al.

Serial No.: 10/026,551

Filed: December 27, 2001

Group Art Unit: 2812

Examiner: Andre C. Stevenson

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SYSTEM FOR

MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Noting the Office Action of June 4, 2003 wherein restriction has been required, Applicant(s) hereby elect Group I (claims 1-7) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

June 3. Rubina

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Date: July 1, 2003